

Notice of References Cited	Application/Control No. 10/724,169	Applicant(s)/Patent Under Reexamination PARK ET AL.	
	Examiner Tianjie Chen	Art Unit 2627	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,339,200	01-2002	Shi et al.	200/305
*	B	US-6,590,848	07-2003	Chen, Chia Hua	720/654
*	C	US-6,678,112 b1	01-2004	Kaneko, Hisashi	360/97.01
*	D	US-5,499,161 a	03-1996	Hosseinzadeh et al.	361/749
*	E	US-2001/0004347	06-2001	Koga et al.	369/116
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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